



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Patent Application of:

Sang-Tae Ahn

Serial No. 10/741,791

Filed: December 19, 2003

METHOD FOR FORMING FLOWABLE DIELECTRIC LAYER IN SEMICONDUCTOR DEVICE

Examiner: Evan T. Pert

Art Unit: 2826

Please enter.

Mail Stop Commissioner for Patents PO Box 1450 Alexandria, Virginia 22313-1450

SUBMISSION OF SUBSTITUTE SPECIFICATION UNDER 37 CF.R. § 1.125

Dear Commissioner:

Applicant submits Substitute Specification as required in the Office Action dated October 3, 2005 under 37 C.F.R. § 1.125. Applicant submits clean and marked up versions of the specification as required. Applicant asserts no new matter has been added to the specification.